



tpw

Patent Application No. 10/777,473  
Attorney Docket No. 81754.0109

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Toshihiko MIYAZAKI

Serial No: 10/777,473

Confirmation No.: 2322

Filed: February 12, 2004

For: Semiconductor Device and Method For  
Manufacturing Semiconductor Device

Art Unit: 2826

Examiner: Quinto, Kevin V.

I hereby certify that this correspondence is  
being deposited with the United States  
Postal Service with sufficient postage as first  
class mail in an envelope addressed to:

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450, on  
November 8, 2004

Date of Deposit  
Joyce Hegeman  
Name  
Signature  
November 8, 2004  
Date

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement dated October 5, 2004, Applicant elects for prosecution the claims of Group I, claims 1, 2 and 9-20, drawn to a semiconductor device, without traverse.

If there are any fees due in connection with the filing of this response, please charge the fees to our Deposit Account No. 50-1314.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: November 8, 2004

By:

Troy M. Schmelzer  
Registration No. 36,667  
Attorney for Applicant(s)

500 South Grand Avenue, Suite 1900  
Los Angeles, California 90071  
Phone: 213-337-6700  
Fax: 213-337-6701